

Docket No.: MICRON.106C1

Customer No.: 20,995

Applicant : Li et al.  
App. No. : 10/027,519  
Filed : December 20, 2001  
For : CHEMICAL TREATMENT OF  
SEMICONDUCTOR  
SUBSTRATES  
Examiner : Victor V. Yevsikov  
Art Unit : 2825

CERTIFICATE OF MAILING

I hereby certify that this correspondence and all marked attachments are being deposited with the United States Postal Service as first-class mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on

November 15, 2004

(Date)

Tina Chen, Reg. No. 44,606

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Certificate  
NOV 23 2004  
of Correction

Sir:

Transmitted herewith for filing in the above-identified application are the following enclosures:

- (X) Certificate of Correction
- (X) Return prepaid postcard.

Tina Chen  
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# UNITED STATES PATENT AND TRADEMARK OFFICE CERTIFICATE OF CORRECTION

**PATENT NO. :** 6,774,058 B2

**DATED :** August 10, 2004

**INVENTOR(S):** Li et al.

It is certified that error appears in the above-identified patent and that said Letters Patent is hereby corrected as shown below:

The patent needs to correctly list both inventors, as stated on the attached declaration. The correct inventors are as listed:

**Li Li and Weimin Li**

Currently, the patent incorrectly lists Li Li as the sole inventor.

MAILING ADDRESS OF SENDER:

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November 15, 2004

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